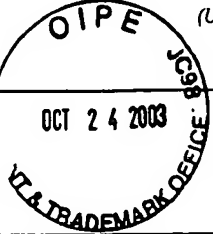


Form PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)				Docket Number 204552028600		Application Number 10/601,755		
				Applicant Takahisa KURAHASHI et al.				
				Filing Date June 24, 2003		Group Art Unit 2811		
				Mailing Date October 23, 2003				
U.S. PATENT DOCUMENTS								
Examiner Initials	Ref. No.	Date	Document No.	Name	Class	Subclass	Filing Date If Appropriate	
DM	1.	12/12/2002	2002/0185653	Kurahashi et al.			5/24/2002	
FOREIGN PATENT DOCUMENTS								
Examiner Initials	Ref. No.	Date	Document No.	Country	Class	Subclass	Translation YES NO	
DM	2.	3/16/2001	JP 2001-68727	Japan			Abstract	
/	3.	3/16/2001	JP 2001-68732	Japan			Abstract	
	4.	3/15/2002	JP 2002-076433	Japan			Abstract	
	5.	4/25/2003	JP 2003-124508	Japan			Abstract	
	6.	7/25/2003	JP 2003-209282	Japan			Abstract	
OTHER DOCUMENTS <small>(including author, title, Date, Pertinent Pages, Etc.)</small>								
Examiner Initials	Ref. No.	Title						
DM	7.	Streubel et al. "High Brightness Visible (660 nm) Resonant-Cavity Light-Emitting Diode" IEEE Photonics Technology Letters, Vol. 10, No. 12, 12/1998, pp. 1685-1687.						
EXAMINER: <i>Kang, Donghee</i>				DATE CONSIDERED: <i>03-17-04</i>				
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